

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Koichiro KOMATSU et al.

Continuation of U.S. Application No.: 09/481,503, filed  
January 12, 2000

Filed: September 15, 2003

Docket No.: 105173.01

For: SURFACE INSPECTION METHOD, SURFACE INSPECTION APPARATUS, AND  
RECORDING MEDIUM AND DATA SIGNAL FOR PROVIDING SURFACE  
INSPECTION PROGRAM

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following:

**Amendments to the Specification; and**

**Remarks.**